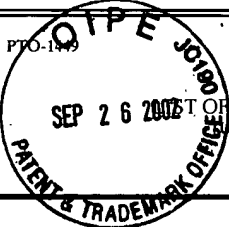


Form PTO-1199 <div style="text-align: center;">  </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1725		SERIAL NO. 09/932,236	
PART OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Haining Yang		FILING DATE August 16, 2001	
GROUP 2813							

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
DA	AA	6,391,797 B1	05/02	Takehiro et al.			
DA	AB	6,358,790 B1	03/02	Fritzinger et al.			
	AC						
	AD						
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	AF						
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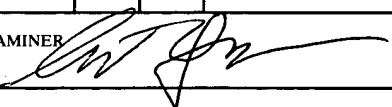
  

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
DA	AR		Van Zant, P., "Microchip Fabrication: A Practical Guide to Semiconductor Processing", McGraw-Hill 4th ed., 2000, pp. 504-505.
	AS		
	AT		

EXAMINER 	DATE CONSIDERED 11-01-02
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.